



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventors: Kenneth C. Johnson et al.

Application No.: 10/621,218

Filed: July 16, 2003

For: METHOD OF MEASURING MESO-
SCALE STRUCTURES ON WAFERS

Confirmation No. 1054

Group Art Unit: 2813

Examiner: Craig A. Thompson


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Atty Docket No.: TWI-30620